

Electronic Articles of Incorporation For

P20000043779
FILED
June 10, 2020
Sec. Of State
dlokeefe

USA WEFV TECHNOLOGY HOLDING GROUP INC.

The undersigned incorporator, for the purpose of forming a Florida profit corporation, hereby adopts the following Articles of Incorporation:

Article I

The name of the corporation is:

USA WEFV TECHNOLOGY HOLDING GROUP INC.

Article II

The principal place of business address:

382 NE 191ST ST
#79525
MIAMI, FL. US 33179

The mailing address of the corporation is:

245 E MAIN STREET
SUITE 107
ALHAMBRA, CA. US 91801

Article III

The purpose for which this corporation is organized is:

CONSTRUCTION MATERIALS

Article IV

The number of shares the corporation is authorized to issue is:

20000

Article V

The name and Florida street address of the registered agent is:

SIZUO YI
382 NE 191ST ST
#79525
MIAMI, FL. 33179

I certify that I am familiar with and accept the responsibilities of registered agent.

Registered Agent Signature: SIZUO YI

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Article VI

The name and address of the incorporator is:

SIZUO YI
382 NE 191ST ST
#79525
MIAMI, FL 33179

Electronic Signature of Incorporator: SIZUO YI

I am the incorporator submitting these Articles of Incorporation and affirm that the facts stated herein are true. I am aware that false information submitted in a document to the Department of State constitutes a third degree felony as provided for in s.817.155, F.S. I understand the requirement to file an annual report between January 1st and May 1st in the calendar year following formation of this corporation and every year thereafter to maintain "active" status.

Article VII

The initial officer(s) and/or director(s) of the corporation is/are:

Title: PTSD
SIZUO YI
382 NE 191ST ST #79525
MIAMI, FL. 33179 US